

PATENT
8017-1189

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Shinji WATANABE et al

Conf. 3401

Application No. 10/574,898

Group 2814

Filed April 6, 2006

Examiner Wai Sing Louie

ELECTRONIC DEVICE AND MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

As the USPTO has waived the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and patent publication for applications filed after June 30, 2003, copies of the cited U.S. references are not enclosed, as the present application is filed after June 30, 2003. Copies of the cited foreign patent documents and/or non-patent literature are enclosed.

A concise explanation of the relevance of these items is that these references were cited by the Chinese Patent Office in Official Action. A copy of the Chinese Official Action in which they were cited is attached hereto, with an English translation.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information con-

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tained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON



Robert J. Patch, Reg. No. 17,355
209 Madison Street, Suite 500
Alexandria, VA 22314
Telephone (703) 521-2297
Telefax (703) 685-0573
(703) 979-4709

RJP/dmw

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